Supplementary Materials for Publication

Compositional Effect on the Fabrication of Ag_xPd_{l-x} Alloy

Nanoparticles on c-Plane Sapphire at Distinctive Stages of the Solid-

State-Dewetting of Bimetallic Thin Films

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Figure S1 Bare sapphire after the degassing at 350 °C for 30 mins. (a) AFM side-view of $3 \times 3 \mu m^2$. (a-1) Corresponding AFM top-view. (b) Raman spectrum of the bare sapphire. In total, 6 peaks are observed in the spectrum: 379, 417, 429, 449, 573 and 751 cm⁻¹. The 416 cm⁻¹ peak is induced by A_{1g} vibrational mode and the other peaks are induced by the E_g vibrational mode. (c) Reflectance spectrum of the bare sapphire.



Figure S2 Ag-Pd bimetallic nanostructures fabricated at 400 °C for 120 s with the deposition thickness of 15 nm and bilayer composition as labelled. (a) – (c) AFM top-views of $3 \times 3 \ \mu m^2$. (a-1) – (c-1) Corresponding line-profiles.



Figure S3 Ag-Pd bimetallic nanostructures fabricated between 500 and 800 °C for 120 s with the deposition thickness of 15 nm. (a) – (l) AFM top-views of $3 \times 3 \ \mu\text{m}^2$. (a-1) – (l-1) Corresponding line-profiles.



Figure S5 Ag-Pd bimetallic nanostrucutres fabricated by the control of deposition thickness between 2 and 30 nm with $Pd_{0.25}Ag_{0.75}$ bilayer composition. The samples were annealed at 650 °C for 120 s. (a) – (h) AFM top-views of 3 × 3 μ m².



Figure S6 Cross-sectional line profiles of the AFM top-views shown in Fig. S5.



Figure S7 Quantative analysis for the Ag-Pd bimetallic nanostrucutres fabricated with the control of deposition thickness as shown in Fig. S5. Diameter (left column) and height (right colume) distribution histograms



Figure S8 Ag-Pd bimetallic nanostrucutres fabricated by the control of deposition thickness between 1 and 30 nm with $Pd_{0.75}Ag_{0.25}$ bilayer composition. The samples were annealed at 650 °C for 120 s. (a) – (h) AFM top-views of 3 × 3 μ m².



Figure S9 Cross-sectional line profiles of the AFM top-views shown in Fig. S8.



Figure S10 Quantative analysis for the Ag-Pd bimetallic nanostrucutres fabricated with the control of deposition thickness as shown in Fig. S8. Diameter (left column) and height (right colume) distribution histograms



Figure S11 Ag-Pd bimetallic nanostrucutres fabricated by the varation of the annealing durations between 0 and 3600 s at 650 °C with the deposition thickness of 10 nm and Pd_{0.25}Ag_{0.75} bilayer composition. (a) – (g) AFM top-views of $5 \times 5 \ \mu m^2$.



Figure S12 Cross-sectional line profiles of the AFM top-views shown in Fig. S11.



Figure S13 Fabrication of Ag-Pd bimetallic nanostrucutres by the varation of the annealing durations between 0 and 3600 s at 650 °C with the deposition thickness of 10 nm and Pd_{0.75}Ag_{0.25} bilayer composition. (a) – (g) AFM top-views of $5 \times 5 \ \mu\text{m}^2$.



Figure S14 Cross-sectional line profiles of the AFM top-views shown in Fig. S13.

Table S1 Summaries of Rq and SAR of the Ag, Pd bimetallic nanostructures fabricated at the control of temperature between 500 and 800 °C for 360 s with the bilayer composition of $Ag_{0.75}Pd_{0.25}$, $Ag_{0.50}Pd_{0.50}$ and $Ag_{0.25}Pd_{0.75}$ with 15 nm total thickness.

| Tempe rature | Ag _{0.75} Pd _{0.25} | | Ag _{0.75} Pd _{0.25} | | | Ag _{0.25} Pd _{0.75} | | | |
|-----------------|---------------------------------------|-------|---------------------------------------|-------|-------|---------------------------------------|-------|-------|----------|
| [°C] | Rq | SAR | Coverage | Rq | SAR | Coverage | Rq | SAR | Coverage |
| 400 | 7.23 | 1.7 | 97.22 | 1.92 | 0.59 | 99.87 | 0.72 | 0.12 | 100 |
| 500 | 13.61 | 5.07 | 84.32 | 2.33 | 0.72 | 99.64 | 0.69 | 0.11 | 100 |
| 600 | 24.56 | 9.83 | 49.28 | 3.67 | 0.65 | 94.97 | 0.91 | 0.13 | 99.63 |
| 700 | 28.55 | 10.52 | 31.73 | 28.3 | 10.68 | 32.15 | 20.46 | 9.11 | 32.73 |
| 800 | 19.46 | 9.49 | 23.42 | 26.16 | 10.86 | 25.69 | 23.38 | 10.73 | 30.16 |

Table S2 Summary of average reflectance of the Ag, Pd bimetallic nanostructures fabricated at the control of temperature between 500 and 800 °C for 360 s with the deposition of $Ag_{0.75}Pd_{0.25}$, $Ag_{0.50}Pd_{0.50}$ and $Ag_{0.25}Pd_{0.75}$.

| Temperature [°C] | Ag _{0.75} Pd _{0.25} | $Ag_{0.50}Pd_{0.50}$ | Ag _{0.25} Pd _{0.75} |
|---------------------|---------------------------------------|----------------------|---------------------------------------|
| 500 | 30.47 | 38.22 | 37.53 |
| 600 | 22.56 | 31.15 | 36.86 |
| 700 | 18.76 | 9.31 | 10.25 |
| 800 | 11.33 | 9.08 | 11.23 |

| DA | | Pd _{0.25} Ag | 0.75 | Pd _{0.75} Ag _{0.25} | | |
|------|-------|-----------------------|----------|---------------------------------------|------|----------|
| [nm] | Rq | SAR | Coverage | Rq | SAR | Coverage |
| 1 | 2.06 | 0.61 | - | 0.96 | 1.49 | - |
| 2 | 4.23 | 2.73 | 87.95 | 1.69 | 5.36 | 74.95 |
| 3 | 8.92 | 4.64 | 80.9 | 5.38 | 8.08 | 49.48 |
| 4 | 9.73 | 10.58 | 69.02 | 7.48 | 8.77 | 39.77 |
| 6 | 13.87 | 15.31 | 44.64 | 17.6 | 7.42 | 32.57 |
| 8 | 14.73 | 9.39 | 39.55 | 13.97 | 6.79 | 43.16 |
| 10 | 14.56 | 12.55 | 43.25 | 18.97 | 7.09 | 41.85 |
| 20 | 15.37 | 8.11 | 74.6 | 16.53 | 4.48 | 70.45 |
| 30 | 41.04 | 16.57 | 28.93 | 49.25 | 8.66 | 28.39 |

Table S3 Summary of Rq and SAR of the samples fabricated at 650 °C for 360 s with variousdeposition thickness of Ag, Pd bi-metallic alloy of $Pd_{0.25}Ag_{0.75}$ and $Pd_{0.75}Ag_{0.25}$.

Table S4 Summary of Rq and SAR of the samples fabricated at 650 °C for 360 s with various deposition thickness of Ag, Pd bi-metallic alloy of $Pd_{0.25}Ag_{0.75}$ and $Pd_{0.75}Ag_{0.25}$. D: diameter; H: height

| DA | Pd _{0.25} | $Ag_{0.75}$ | Pd _{0.75} Ag _{0.25} | | |
|------|--------------------|-------------|---------------------------------------|-------|--|
| [nm] | D | Н | D | Н | |
| 2 | 38.12 | 3.51 | 43.22 | 8.59 | |
| 3 | 83.57 | 18.43 | 72.03 | 15.81 | |
| 4 | 101.26 | 22.42 | 104.79 | 27.56 | |
| 6 | 125.35 | 31.22 | 166.37 | 43.11 | |
| 8 | 166.3 | 36.16 | 212.47 | 45.14 | |
| 10 | 193.77 | 54.24 | 217.6 | 48.25 | |

| DA [nm] | Pd _{0.25} Ag _{0.75} | Pd _{0.75} Ag _{0.25} |
|---------|---------------------------------------|---------------------------------------|
| 1 | 8.75 | 8.36 |
| 2 | 9.72 | 8.58 |
| 3 | 10.74 | 11.74 |
| 4 | 11.84 | 12.03 |
| 6 | 15.03 | 14.09 |
| 8 | 16.5 | 13.11 |
| 10 | 16.3 | 17 |
| 20 | 24.39 | 22.35 |
| 30 | 9.13 | 8.64 |

Table S5 Summary of average reflectance of the samples fabricated at 650 °C for 360 s with various deposition thickness of Ag, Pd bi-metallic alloy of $Pd_{0.25}Ag_{0.75}$ and $Pd_{0.75}Ag_{0.25}$.

| DA [nm] | Pd _{0.25} Ag _{0.75} | Pd _{0.75} Ag _{0.25} |
|---------|---------------------------------------|---------------------------------------|
| 1 | 1949.16 | 2396.05 |
| 2 | 2156.49 | 2200.71 |
| 3 | 1741.27 | 1887.58 |
| 4 | 1715.87 | 1550.67 |
| 6 | 1261.07 | 1213.89 |
| 8 | 1380.83 | 960.31 |
| 10 | 1121.68 | 1047.5 |
| 20 | 1000.64 | 593.93 |
| 30 | 1037.53 | 755.4 |

Table S6 Summary of Raman intensities of the samples fabricated at 850 °C for 360 s withvarious deposition thickness of Ag, Pd bi-metallic alloy of $Pd_{0.25}Ag_{0.75}$ and $Pd_{0.75}Ag_{0.25}$.

| Annealing Duration | Pd _{0.25} Ag _{0.75} | | | Pd _{0.75} Ag _{0.25} | | |
|-----------------------|---------------------------------------|-------|----------|---------------------------------------|------|----------|
| [s] | Rq | SAR | Coverage | Rq | SAR | Coverage |
| 0 | 28.7 | 15.52 | 51.37 | 18.44 | 6.13 | 61.77 |
| 60 | 29.97 | 16.07 | 48.95 | 19.3 | 6.57 | 54.7 |
| 240 | 28.91 | 15.61 | 48.17 | 20 | 6.84 | 51.5 |
| 450 | 26.73 | 14.27 | 45.58 | 19.06 | 7.19 | 49.57 |
| 900 | 23.86 | 11.82 | 38.23 | 18.82 | 6.59 | 50.72 |
| 1800 | 21.89 | 10.92 | 35 | 15.49 | 4.96 | 48.77 |
| 3600 | 21.06 | 10.64 | 34.3 | 16.31 | 5.04 | 47.43 |

Table S7 Summary of Rq and SAR of the samples fabricated with the control of annealingduration at 800 °C with various Ag, Pd bi-metallic alloy of $Pd_{0.25}Ag_{0.75}$ and $Pd_{0.75}Ag_{0.25}$

Table S8 Summary of average reflectance of the samples fabricated with the control ofannealing duration at 800 °C with various Ag, Pd bi-metallic alloy of $Pd_{0.25}Ag_{0.75}$ and $Pd_{0.75}Ag_{0.25}$

| Annealing Duration [s] | Pd _{0.25} Ag _{0.75} | Pd _{0.75} Ag _{0.25} |
|---------------------------|---------------------------------------|---------------------------------------|
| 0 | 20.3 | 18.16 |
| 60 | 18.55 | 16.82 |
| 240 | 18.22 | 16.58 |
| 450 | 17.6 | 16.48 |
| 900 | 16.75 | 16.44 |
| 1800 | 14.05 | 16.34 |
| 3600 | 12.16 | 16.69 |